

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Kazuya Fujita et al.

Application No.: 10/773,809

Confirmation No.: 8452

Filed: February 5, 2004

Art Unit: 2814

For: SOLID STATE IMAGING DEVICE,
SEMICONDUCTOR WAFER, OPTICAL DEVICE
MODULE, METHOD OF SOLID STATE
IMAGING DEVICE FABRICATION, AND
METHOD OF OPTICAL DEVICE MODULE
FABRICATION

Examiner: W. S. Louie

AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated August 1, 2008, please consider and enter the following Response.

Applicants believe that no extension of time is required since this response is being filed before the expiration of the specified time period. Applicants, however, conditionally petition for an extension of time to provide for the possibility that such a petition has been inadvertently overlooked and is required. As provided below charge Deposit Account No. **04-1105** for any required fee.

The Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 10 of this paper.